



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 15, 2026	
IGI Report Number	LG801606262
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	9.22 X 7.18 X 4.82 MM

GRADING RESULTS

Carat Weight	2.52 CARATS
Color Grade	E
Clarity Grade	VS 1

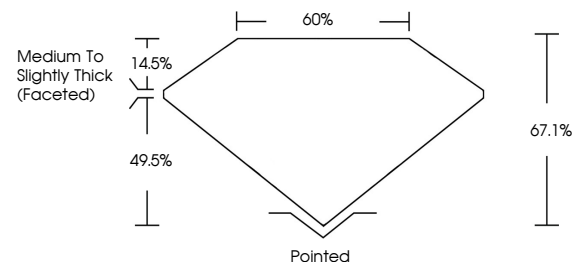
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG801606262

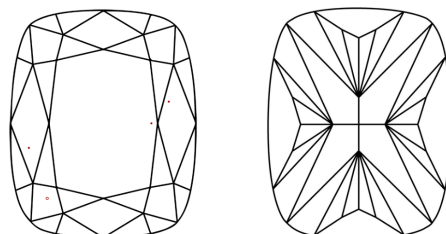
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG801606262
Report verification at lqi.org

PROPORTIONS

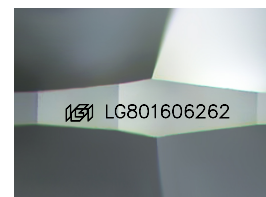


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

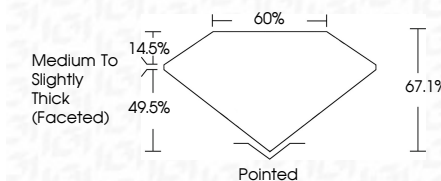
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

May 15, 2026	VS 1	Polished
G1 Report No. LG80160262	67.1%	EXCELLENT
CUSHION MODIFIED BRILLIANT	65%	EXCELLENT
	Medium to Slightly Thick Faceted	NONE
		lg81LG80160262

Comments:

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Type IId